

PTO/SB/08a/b (08-03)
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Substitute for form 1449A/B/PTO				Complete if Known			
				Application Number 10/807,537			
	NFORMATION	I DI	SCLOSURE	Filing Date	March 23, 2004		
S	STATEMENT BY APPLICANT			First Named Inventor	Yehuda Shekel		
				Art Unit	N/A 1763		
(Use as many sheets as necessary)				Examiner Name	Not Yot Assigned Culbert		
Sheet	1	of	2	Attorney Oocket Number	06727/0201090-US0		

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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Data MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
RC	AA**	US-5,376,214-B1	12/1994	lwasaki, et al.		
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^{**} Pursuant to the Notice issued by the United States Patent and Trademark Office dated July 11, 2003 walving the requirements of 37 C.F.R. § 1.98(a)(2)(i), a copy/copies of the United States Patent on PTO/SB08 is/are not being submitted.

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁴ (Il known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	⊤ಿ	
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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
RC	CA	De Keersmacker, R., Dielectric Breakdown in Thermally Growing Oxide Layer, Chapter 7, Katolieke Universitett Leuven, Belgium 1993.			
RC	СВ	Judge, John S., "A Study of the Dissolution of SiO2 in Acidic Fluoride Solutions", J. Electrochem. Soc., November 1971, pp. 1772-1775.			

Examiner /Roberts Culbert	/ Date	05/30/2006
Signature / Roberts Curbert	Considered	03/30/2006

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	(Use as many sl	reets as	necessary)	Examiner Name	Not Yot Assigned Culbert		
Sheet	2	af	2	Attorney Docket Number	06727/0201090-US0		

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	CE	Burns, Donald, et al., ed., "Handbook of Near-Infrared Analysis", Marcel Dekker Inc., 1992.	
	CF	Kashkoush, Ismail, et al., "In-Situ Chemical Concentration Control for Wafer Wet Cleaning", Mat. Res. Soc. Symp. Proc. (1997), Vol. 477, p. 311-316.	
	CG	Fischer, Wolfgag B., et al., "Corrections to the Baseline Distortions in the OH-Stretch Region of Aqueous Solutions", Appl. Spec. 1994, Vol. 48 (1), pp. 107-112.	
RC	СН	Thompson, Christopher J., et al., "Quantification of Hydrofluoric Acid Species by Chemical- Modeling Regression of Near-Infrared Spectra", Anal. Chem. 1997, Vol. 69, pp. 25-35.	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

^{&#}x27;Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.